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	Filing Date		2003-07-22
	First Named Inventor	Issaq et al.	
	Art Unit	2811	
	Examiner Name	Tran, Thien F.	
	Attorney Docket Number	ACT-377	

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	2	5807786	A	1998-09-15	Chang	
	3	5838530	A	1998-11-17	Zhang	
	4	5965270	A	1999-10-12	Fang et al.	
	5	6124193	A	2000-09-26	Hawley et al.	
	6	6130572	A	2000-10-10	Ghiardelli et al.	
	7	6259130	B1	2001-07-10	Wu	
	8	6316346	B1	2001-11-13	Gangopadhyay	

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9	6529038	B2	2003-03-04	Lambertson	
10	6630396	B2	2003-10-07	Yang et al.	
11	6674667	B2	2004-01-06	Forbes	
12	6728126	B1	2004-04-27	Issaq et al.	
13	6767769	B2	2004-07-27	Hawley et al.	
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	5	1461824	EP	A2	2004-09-29	Actel Corporation		<input type="checkbox"/>
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